## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

atent of:	§	
Weimer	§	Attorney Docket: 40232.78
	§	
No.: 09/852,992	§	Confirmation No.: 5859
•	§	
May 10, 2001	§	Patent Number: 6,838,121
•	§	
System and Method for Controlling	§	Issue Date: January 4, 2005
Deposition Parameters in Producing a	§	
Surface to Tune the Surface's Plasmon	§	Customer Number: 27683
Resonance Wavelength	§	
	No.: 09/852,992  May 10, 2001  System and Method for Controlling Deposition Parameters in Producing a	Weimer §  No.: 09/852,992 §  May 10, 2001 §  System and Method for Controlling §  Deposition Parameters in Producing a §  Surface to Tune the Surface's Plasmon §

United States Patent and Trademark Office PO Box 371611 Pittsburgh, PA 15250-1611

## **NOTIFICATION OF CHANGE IN ENTITY STATUS**

Dear Sir:

Patentee, by undersigned attorney, hereby requests the above-identified patent, be withdrawn from LARGE ENTITY STATUS.

The subject patent was filed on May 10, 2001 and included a claim for Small Entity status. A copy of the Filing Receipt is attached herewith. The United States Patent and Trademark Office incorrectly listed the patent as being subject to Large Entity fees on the Notice of Allowance and Maintenance Fee Payment System.

Therefore, in accordance with C.F.R. §1.27(g)(1), Patentee hereby notifies the patent office that the above-noted patent is and always has been entitled to SMALL ENTITY STATUS.

Respectfully submitted,

Dated: 12 AVG 2008

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D1671707.1

David L. McCombs Registration No. 32,271

CERTIFICATE OF TRANSMISSION UNDER 37 CFR §1.8 I hereby certify that this correspondence and any corresponding filing fee is being transmitted via the Electronic Filing System (EFS) Web with the United States Patent and Trademark Office on Aug UST 12, 2008

RANDI ROSS-OVICE

Printed Name

Rend Ron-Quich

Signature



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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY.DOCKET.NO	DRAWINGS	TOT CLAIMS	IND CLAIMS	
APPLICATION NOMBER				50767-	•	57	. 5	
09/852,992	05/10/2001	1762	768	P013US-	О	57	•	

**CONFIRMATION NO. 5859** 

FILING RECEIPT

David H. Tannenbaum FULBRIGHT & JAWORSKI L.L.P. Suite 2800 2200 Ross Avenue Dallas, TX 75201



Date Mailed: 07/09/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Wayne A Weimer, Plano, TX;

Assignment For Published Patent Application

Zyvex Corporation;

Domestic Priority data as claimed by applicant

Foreign Applications

Projected Publication Date: Request for Non-Publication Acknowledged

Non-Publication Request: Yes

Early Publication Request: No

\*\* SMALL ENTITY \*\*

Title

System and method for controlling deposition parameters in producing a surface to tune the

